

Notice of References Cited	Application/Control No. 09/819,810	Applicant(s)/Patent Under Reexamination YAMAWAKI ET AL.	
	Examiner Huy Q Phan	Art Unit 2685	Page 1 of 1

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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